Docket No.: 2336-259 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Sang Ho YOON et al.

U.S. Patent Application No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: Herewith

For: SEMICONDUCTOR LASER DIODE WITH HIGHER-ORDER MODE

**ABSORPTION LAYERS** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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BJH/ayh

INFO	ORMATION	DISCLOSURE	ATTY. DOCKET NO. 2336-259		U.S. APPLICATION NO. Not yet assigned	
	CITATION APPLICA	N IN AN	APPLICANT Sang Ho YOON et al.			
(PTO-1449)			FILING DATE herewith		GROUP	
		U.S. PATENT	DOCUMENTS			
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,172,998	01/2001	Horie et al.			
	6,366,595	04/2002	Bowler			
		FOREIGN PATE	NT DOCUMENTS			
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes No
	ОТНЕ	 RART (Including Author	Title, Date, Pertine	nt Pages, E	 (c.)	
EXAMINER	DATE CONSIDERED					

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.